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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* *NO*\*\* FOREIGN APPLICATIONS \*\*\*\*\* *YES*

JAPAN 2003-149057 05/27/2003 NO

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/11/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>	JAPAN	3	15	3

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## TITLE

Etching method and semiconductor device fabricating method

FILING FEE

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